

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Kazuya Fujita et al.

Application No.: 10/773,809

Confirmation No.: 8452

Filed: February 5, 2004

Art Unit: 2814

For: SOLID STATE IMAGING DEVICE,  
SEMICONDUCTOR WAFER, OPTICAL DEVICE  
MODULE, METHOD OF SOLID STATE  
IMAGING DEVICE FABRICATION, AND  
METHOD OF OPTICAL DEVICE MODULE  
FABRICATION

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Examiner: W. S. Louie

**AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated August 1, 2008, please consider and enter the following Response.

Applicants believe that no extension of time is required since this response is being filed before the expiration of the specified time period. Applicants, however, conditionally petition for an extension of time to provide for the possibility that such a petition has been inadvertently overlooked and is required. As provided below charge Deposit Account No. **04-1105** for any required fee.

**The Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 10 of this paper.